L Number	Hits	Search Text	DB	Time stamp
2	433	430/11,5,30.ccls. and lens and lithographic and mask	USPAT	2004/09/07 18:00
1	42	430/11,5,30.ccls. and (lens near10 semiconductor) and lithographic and mask	USPAT	2004/09/07 18:54
3	1	430/11,5,30.ccls. and (lens near10 semiconductor) and lithographic and mask and (mask same pull$1back)	USPAT	2004/09/07 18:01
4	17	430/296,311,320,321.ccls. and (lens near10 semiconductor) and lithographic and mask	USPAT	2004/09/07 18:56
5	3	257/432,98.ccls. and (lens near10 semiconductor) and lithographic and mask	USPAT	2004/09/07 18:56
-	3733	(lens near material) and lens.ab.	USPAT	2004/09/01 21:59
-	7	BOETTIGER.in. and ULRICH	USPAT	2004/09/01 21:25
-	5	(BOETTIGER.in. and ULRICH) and lens	USPAT	2004/09/01 21:25
-	4	BOETTIGER.in. and ULRICH	US-PGPUB	2004/09/01 21:25
-	178	((lens near material) and lens.ab.) and wafer	USPAT	2004/09/01 21:59
-	109	((lens near material) and lens.ab.) and (wafer with lens)	USPAT	2004/09/02 18:31
-	832	lens near2 semiconductor	USPAT	2004/09/02 18:31
-	279	lens near semiconductor	USPAT	2004/09/02 20:27
-	143	(lens near semiconductor) and lens.ab.	USPAT	2004/09/02 21:32
-	63	(lens near semiconductor) and mask	USPAT	2004/09/02 18:32
-	24	(lens near semiconductor) and lens.ab. and mask	USPAT	2004/09/02 19:12
-	51	(lens with semiconductor) and lens.ab. and mask and micro$1lens	USPAT	2004/09/02 19:12
-	16	(lens with semiconductor) and lens.ab. and (mask same micro$1lens)	USPAT	2004/09/02 19:12
-	40	lens near semiconductor and method and (coat$3 and expos$3 and remov$4)	USPAT	2004/09/02 21:32
-	40	(lens near semiconductor) and method and (coat$3 and expos$3 and remov$4)	USPAT	2004/09/02 20:33
-	9	(lens near semiconductor) and lens.ab. and lithographic and mask	USPAT	2004/09/02 21:33
-	27	(lens near10 semiconductor) and lens.ab. and lithographic and mask and array	USPAT	2004/09/02 21:33
-	1	359/618,621,623.ccls. and (lens near10 semiconductor) and lens.ab. and lithographic and mask and array	USPAT	2004/09/03 13:27
-	18	("4326800" | "4490039" | "5233174" | "5463649" | "5493391" | "5539718" | "5610897" | "5825476" | "5828455" | "5864381" | "5912731" | "5936720" | "5936739" | "5939716" | "5978085" | "6052180" | "6130419" | "6184974").PN.	USPAT	2004/09/02 21:42
-	2	430/321,396.ccls. and (lens near10 semiconductor) and lens.ab. and lithographic and mask and array	USPAT	2004/09/03 13:27
-	0	430/1,2,4,5,6.ccls. and (lens near10 semiconductor) and lens.ab. and lithographic and mask and array	USPAT	2004/09/07 17:59